

TCAD simulation III

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Overview

- **Simulation example of 2D PN junction using SDEVICE**
- **Charge generation and collection**

TCAD simulation SDEVICE

TCAD Synopsys Simulation

- **Sentaurus Device** is a numeric semiconductor device simulator, capable of simulating the electrical, thermal, and optical characteristics of various semiconductor devices.
- It simulates 1D, 2D, and 3D device behaviour over a wide range of operating conditions, including mixed-mode circuit simulation, combining numerically simulated devices with their compact modeling, which is performed on a SPICE-based circuit simulation level.

1 **File Section:** input/output files

2 **Electrode Section:** electrode definition, matching those in the input grid

3 **Physics Section:** physics models to use in the simulation

4 **Plot Section:** variables to plot

5 **Math Section:** solvers

6 **Solve Section:** what to solve (IV,CV, Charge injection)

A typical command file of Sentaurus Device consists of several sections (or statement blocks), with each section executing a relatively independent function. The default extension of the command file is `_des.cmd`, for example, `pp1_des.cmd`. To start: **sdevice**



TCAD Synopsys Simulation

- SDEVICE simulation of 2D pn junction
 - **Charge generation**
- Within SDEVICE, charge injection by particles can be modelled using the models for carrier generation by gamma radiation, alpha particles and heavy ions (optical generation is also available)
- Heavylon generation:

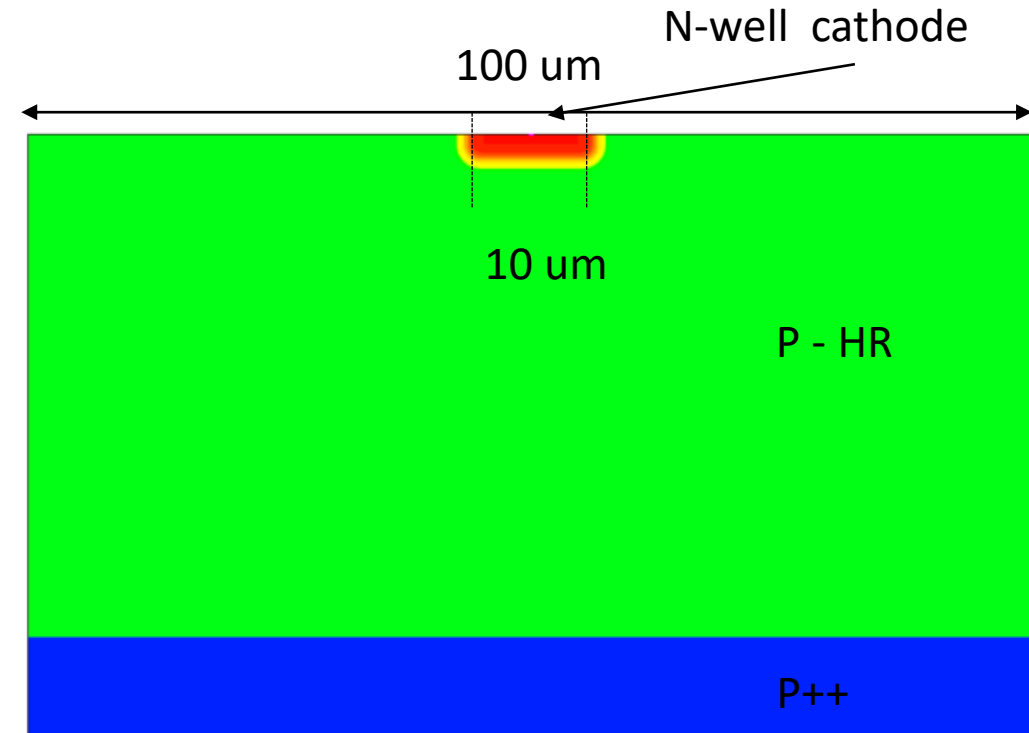
$$G(l,w,t)=G_{let}(l)R(w,l)T(t)$$

G_{let} : linear energy transfer(LET) generation density

$R(w,t)$: spatial distribution (exponential/Gaussian)

$T(t)$: temporal profile

				
TwoDsde	sdeviceV_REV	deviceV_FWL	deviceCV_RE	sdeviceCCE
	Temp			Vbias
	[n2] 280	[n6] --	[n9] --	[n15] --
				[n12] 100



TCAD Synopsys Simulation

- SDEVICE command file: transient analysis:
- - **File Section:** input/output files
 - **Electrode Section:** electrode definition, matching those in the input grid
 - **Physics Section:** physics models to use in the simulation
 - **System:** defines a mixed mode setup consisting of the device(s) and sources attached to it
 - **Plot Section:** variables to plot
 - **Math Section:** solvers to use

```
#####      2D PN junction CCE analysis      #####

#define Vdd @Vbias@
#define HitTime 1e-8
#define HitTime_Step 1e-11
#define Transient_Time 5e-9

## Input and Output Files

Device PNjnt  {
                                File {
                                grid    = "2D_PNjnt_msh.tdr"
                                }
}
```

TCAD Synopsys Simulation

- SDEVICE command file: physics section
 - **The ionisation is obtained by a Minimum Ionising Particle (MIP)**
 - **Details of the ionisation are included in a file (MIP_EXC) which has the LET and spatial parameters required for MIP emulation**

```
Physics {
```

```
#####if "@Ionization@"=="MIP"
```

```
#include "MIP_EXC"
```

```
...
```

```
#define WT_hi 0.1
```

```
        Heavylon (
```

```
Time = HitTime
```

```
Location = (0, 0) ##### Hits at the top surface, right in the middle of the device
```

```
Direction = (1.0,0.0) ##### Perpendicular hit
```

```
#####LET_f = [1.28e-5 1.28e-5 1.28e-5] ##### 80 e/h per micron is 1.28E-5 for THICK sensor
```

```
LET_f = [1.056e-5 1.056e-5 1.056e-5] ##### 66 e/h per micron as MPV for 50 um thick  
active region
```

```
##### LET_f = [1.15e-5 1.15e-5 1.15e-5] ##### 72 e/h per micron as MPV for 300 um thick  
active region
```

```
Wt_hi = [WT_hi WT_hi WT_hi] ##### ro = 0.1/0.2 micron
```

```
Length = [ 0.0 20 60 ] ##### LET @ different depths, irrelevant for a MIP
```

```
PicoCoulomb
```

```
Gaussian
```

```
)
```

TCAD Synopsys Simulation

- SDEVICE command file: solve
 - The voltage is first ramped up to the required bias voltage
 - Then the transient simulation starts
 - The time resolution is increase just before the hit

Solve procedure

Solve {

Coupled(Iterations= 700 LineSearchDamping= 1e-4){ Poisson }

Coupled(Iterations= 70 LineSearchDamping= 1e-4){ Poisson Electron Hole }

DC bias

NewCurrentPrefix="2D_PNjct_Temp@Temp@_CCE_DCVbias@Vbias@"

ramps up to the max Vbias for CCE investigation

```

                Quasistationary
            (
                InitialStep= 1e-3 MinStep= 1e-15 MaxStep= 0.25
                Increment= 2.0 Decrement= 4.0
                Goal { Parameter = vc.dc voltage = Vdd }
            )
                {
                    Coupled { Poisson Electron Hole } }

```

Starts the transient

NewCurrentPrefix="2D_PNjct_Temp@Temp@_CCE_TRVbias@Vbias@"

initial reset time until HIT_Time - 10ps...

```

Transient (    InitialTime = 0 FinalTime = @<HitTime-0.01e-9>@
                InitialStep = 1e-9 MaxStep = 2e-9
MinStep = 1e-15 )
                {
                    Coupled (Iterations = 10 ) { Poisson Electron Hole }
                }

```

TCAD Synopsys Simulation

- SDEVICE command file: solve
- When the particle hits the devices, the temporal resolution is optimised for the first ns, it is relaxed afterwards

starts the transient analysis in 'HiRes' , set by Hit_Time_Step, until Hit_time + 1 ns

```

Transient (      InitialTime = @<HitTime-0.01e-9>@
FinalTime = @<HitTime+1e-9>@
                                InitialStep = 0.1e-12 MaxStep
= HitTime_Step MinStep = 1e-15 )
                                { Coupled (Iterations = 5 ) { Poisson
Electron Hole }

```

```

Plot ( FilePrefix =
"2D_PNjct_Temp@Temp@_CCE_TRVbias@Vbias@"

```

```

Time = (
                                HitTime
                                ) NoOverwrite )
}

```

after the first 1 ns after the hit the transient is in 'MediumRes' of 0.1 ns

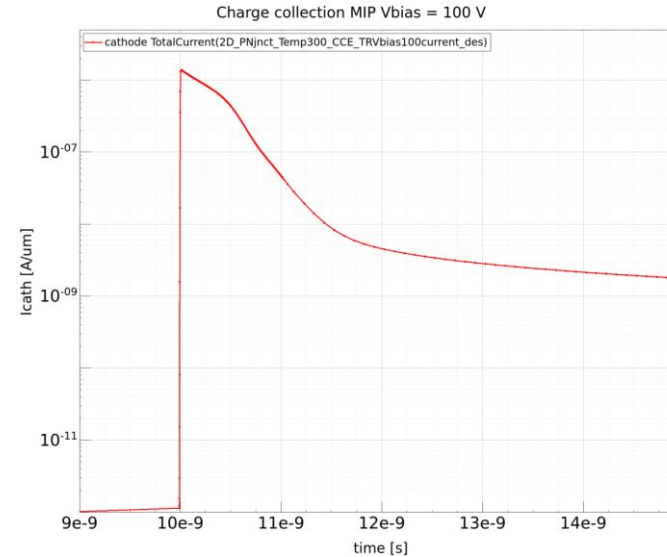
```

Transient (      InitialTime = @<HitTime+1e-9>@ FinalTime =
@<HitTime+Transient_Time>@
                                InitialStep = 1e-12 MaxStep =
.1e-9 MinStep = 1e-15 )
                                {
                                Coupled (Iterations = 10 ) { Poisson
Electron Hole }

```

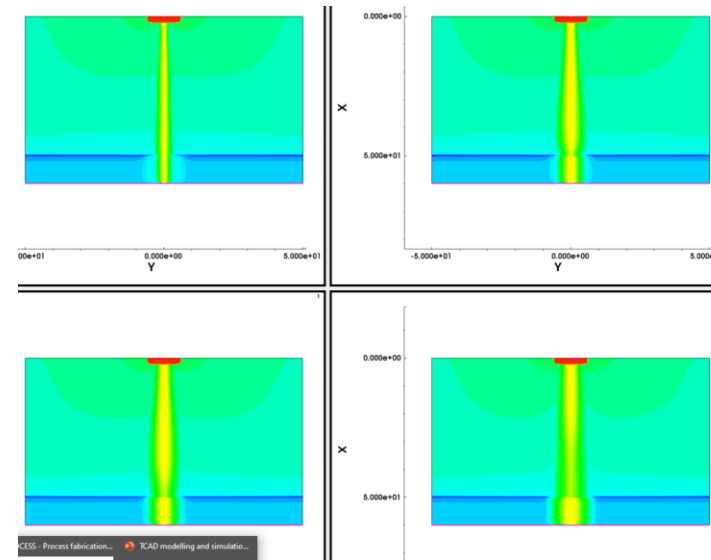
TCAD Synopsys Simulation

- Visualize the resulting mesh using **SVISUAL**
 - Re-mesh the structure changing the p – doping
 - Visualise the meshing
 - I transient vs. bias
 - Charge collected vs. bias
 - Plots of charge density vs. time



Icathode transient
– MIP hit @ 10 ns -:
No Ramo's theorem used

$$Q = \oint \epsilon \vec{E} \cdot d\vec{S}$$



Icathode transient
– MIP hit @ 0, 100, 200, 500
ps

Thank you

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- Simulation example : 2D pn using SDEVICE
- Charge generation and collection from MIP hit